

ABSTRACT OF THE DISCLOSURE

A substrate alignment apparatus which aligns and
fixes a substrate on a substrate stage includes a
chucking pad fixed on the substrate stage to chuck and
5 fix the substrate, a moving unit which moves the
substrate with respect to the substrate stage such that
a mark on the substrate stage and a mark on the
substrate coincide with each other, and a determination
unit which manages a relative position between the
10 chucking pad and the substrate after movement by the
moving unit and determines whether the chucking pad can
normally chuck the substrate.